



**ELECTRONIC COPY**

LG657466601  
Report verification at igi.org



October 10, 2024

IGI Report Number **LG657466601**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **EMERALD CUT**

Measurements **7.09 X 4.80 X 3.18 MM**

**GRADING RESULTS**

Carat Weight **1.09 CARAT**

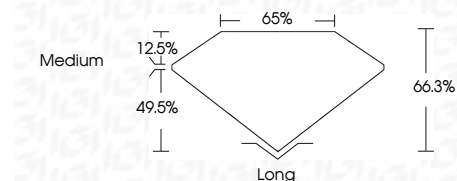
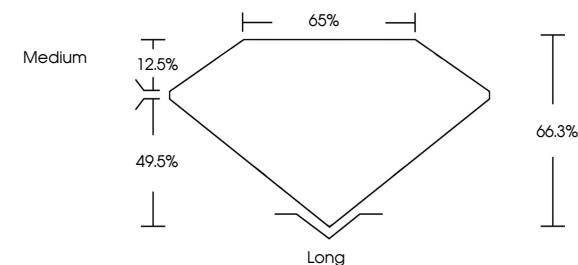
Color Grade **E**

Clarity Grade **VS 1**

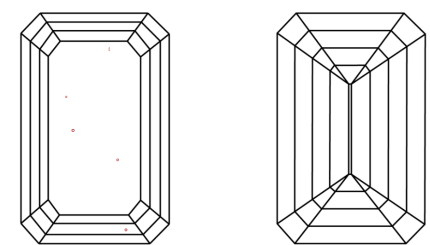


Sample Image Used

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D	E	F	G	H	I	J	Faint	Very Light	Light
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**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG657466601**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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**EMERALD CUT**

**7.09 X 4.80 X 3.18 MM**

Carat Weight **1.09 CARAT**  
Color Grade **E**  
Clarity Grade **VS 1**  
Depth **49.5%**  
Table **12.5%**  
Girdle **Medium**

Culet **Long**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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